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Docket: 0756-1603

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of

SHUNPEI YAMAZAKI et al

Serial No. 08/841,644 -

Filed: 04/30/1997 -

For: SEMICONDUCTOR DEVICE AND

METHOD FOR FORMING THE SAME



) Group Art Unit: 1104

) Examiner: L. Radomsky

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INFORMATION DISCLOSURE STATEMENT

CERTIFICATE OF MAILING

Honorable Assistant Commissioner of Patents

Washington, D.C. 20231

Sir:

I hereby certify that
correspondence is being sent by
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Commissioner for Patent and Trademark
D.C. 20231 on 7/25/00

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith attached Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Each item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a foreign application not more than three months prior to the filing of the information disclosure statement.

Full translations or concise statements of Japanese Patent Laid-Open Publications 46-3025, 48-22285, 47-18278 and Japanese Utility Model Laid-Open Publication 2-148132 will be submitted shortly.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,



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